

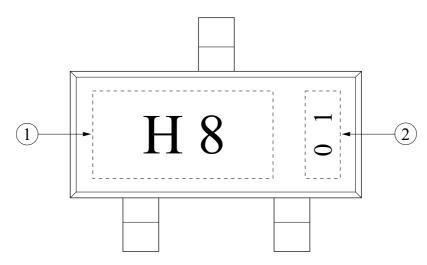
SEMICONDUCTORMARKING SPECIFICATION

BAV99 SOT-23 PACKAGE

1. Marking method

Laser Marking

2. Marking



No.	Item	Marking	Description
1	Device Mark	Н8	BAV99
	-	-	-
2	* Lot No.	01	2002. 1st Week [0:1st Character, 1:2nd Character]

Note) * Lot No. marking method

Lot No.	Description	Remark
01, 0251, 52	01 : 2002. 1st Week, 02 : 2002. 2nd Week	
	51: 2002. 51th Week, 52: 2002. 52th Week.	Rotation for 4 years: 0152:2002, 2006, 2010 0A5B:2003, 2007, 2011 J1E2:2004, 2008, 2012 JAEB:2005, 2009, 2013
0A 0D 5A 5D**	0A: 2003. 1st Week, 0B: 2003. 2nd Week	
0A, 0B5A, 5B**	5A: 2003. 51th Week, 5B: 2003. 52th Week.	
J1, J2E1, E2**	J1 : 2004. 1st Week, J2 : 2004. 2nd Week	
, ,	E1: 2004. 51th Week, E2: 2004. 52th Week.	
IA ID DA ED##	JA: 2005. 1st Week, JB: 2005. 2nd Week	
JA, JBEA, EB**	EA: 2005. 51th Week, EB: 2005. 52th Week.	